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SERIAL NUMBER 10/698,356	FILING DATE 11/03/2003 RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. 04329.2802-01
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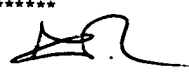
APPLICANTS

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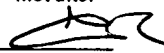
** CONTINUING DATA *****

This application is a DIV of 10/107,247 03/28/2002 PAT 6,689,625 

** FOREIGN APPLICATIONS *****

JAPAN 2001-095971 03/29/2001 

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature 	Initials		

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 22852
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TITLE
 Photomask manufacturing method, photomask manufactured by said manufacturing method, and semiconductor device method using said photomask

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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